Femtosecond micromachining in polymers

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focus laser beam inside material or on its surface



photon energy < bandgap



nonlinear interaction

nonlinear interaction



nonlinear interaction



multiphoton absorption

it is important to understand the nonlinear interaction, as well as the nonlinear response of organic compounds and polymers

applications:

- data storage
- waveguides
- microfluidics
- biology



Polymers and organic materials

Outline

Introduction to nonlinear optics

fs-micromachining microstructuring MEH-PPV waveguides in azopolymers

two-photon polymerization birefringent microstructures fluorescent microstructures biocompatible microstructures

Linear optics





harmonic oscillator

linear response

$$P = \chi E$$

Nonlinear optics



high light intensity



anharmonic oscillator

nonlinear polarization response

$$P = \chi^{(1)}E + \chi^{(2)}E^2 + \chi^{(3)}E^3 + \dots$$

two-photon absorption



two-photon absorption

Nonlinear interaction provides spatial confinement of the excitation



 $\alpha = \alpha_0$

 $\alpha = \alpha_0 + \beta I$

femtosecond pulses



femtosecond pulses



repetitive

cumulative

fs-pulses for micromachining polymers

Oscillator: 80 MHz, 5 nJ



heat diffusion time: $t_{diff} \sim 1 \ \mu s$

cumulative

fs-microfabrication

linear versus nonlinear absorption



fs-microfabrication

Nonlinear interaction provides spatial confinement of the excitation



 $\alpha = \alpha_0$

 $\alpha = \alpha_0 + \beta I$

two main techniques



fs-laser micromachining

ablation structural modification



microfabrication via two-photon polymerization



Micromachining the conductive polymer MEH-PPV

optical microscopy



a: 0.07 nJ **b:** 0.14 nJ **c:** 0.34 nJ **d:** 0.68 nJ

Micromachining the conductive polymer MEH-PPV



atomic force microscopy



Micromachining the conductive polymer MEH-PPV



Waveguides in azo-polymers







DR13





DR1

Waveguides in azo-polymers - photobleaching



Absorbance spectrum of PMMA films containing 3.5% by weight of (a) DO3, (b) DR1, and (c) DR13. The dashed lines show the absorbance after micromachining the films.

Waveguides in azo-polymers





- (a) Optical microscope image of the waveguides micromachined (PMMA/DR1)
- (b) Cross-sectional view of the waveguides

waveguides in azo-polymers



(c) Output image of the mode profile of 632.8-nm light coupled through the waveguide

photonic devices - wiring optoelectronics circuits of the future

3D wave splitter



photonic devices - wiring optoelectronics circuits of the future



3D splitter



Bragg grating



demultiplexer

laser active glass

amplifier



interferometer

Curved waveguides



microstructuring polymer: super hydrophobic surface





M.R. Cardoso and C. R. Mendonca

microstructuring polymer



microstructuring polymer



width and depth control

microstructuring polymer



flat surface

$\theta = 118^{\circ}$









Two-photon polymerization



Two-photon polymerization



even higher spatial resolution

Two-photon polymerization setup



Two-photon polymerization





Resin Preparation

Monomers

SR499



SR368



reduces the shrinkage upon polymerization

gives hardness to the polymeric structure

Photoinitiator



Two-photon polymerization





30 μm x 30 μm x 12 μm cube



Two-photon polymerization



After the fabrication, the sample is immersed in ethanol to wash away any unsolidified resin and then dried

Microstructures fabricated by two-photon polymerization











Microstructures containing active compounds



Applications of two-photon polymerization

Optics and Photonics

Doping microstructures with organic molecules and metals

fluorescence birefringence conductivity

Bio-applications

Fabrication using bio-compatible resins to biological applications

tissue engineering scaffolds fabrication of microneedle cell study

Applications

1) Optically induced birefringence

2) Emission and conduction

3) Biocompatible microstructure



Incorporating the azodye DR13 into the microstructure



Molecular orientation by excitation with linearly polarized light



After alignment



Optically Induced birefringence







Ar+ ion laser irradiation

- 514.5 nm
- one minute
- intensity of 600 mW/cm²

The sample was placed under an optical microscope between crossed polarizers and its angle was varied with respect to the polarizer angle



The structure is visible when the angle between the birefringence axis and the polarizer is an odd multiple of 45°



∆**n= 5x10**⁻⁵

This birefringence can be completely erased by irradiating the sample with circularly polarized light.

Applications: micro-optical switch, micro-optical storage



The structure is visible when the angle between the birefringence axis and the polarizer is an odd multiple of 45°



This birefringence can be completely erased by irradiating the sample with circularly polarized light.



Fluorescence Electro Luminescent Conductive



- (a) Scanning electron microscopy
- (b,c) Fluorescence microscopy of the microstructure with the excitation OFF (b) and ON (c)
- (d) Emission of the microstructure (black line) and of a film with the same composition (red line)



Fluorescent confocal microscopy images in planes separated by 16 μ m in the pyramidal microstructure.













waveguiding of the microstructure fabricated on porous silica substrate (n= 1.185)

Applications: micro-laser; fluorescent microstructures; conductive microstructures

20 µm

microstructures containing chitosan



Applications

biodegradability biocompatibility bone regeneration drug-delivery bactericide action blood coagulation



Microstructures show excellent integrity and good definition

3D cell migration studies in micro-scaffolds



schematic of the scaffold



SEM of the scaffolds 110 µm pore size

52 µm pore size

Top view

110, 52, 25, 12 μm pore size

Side view

25, 52 μm pore size cell migration

50 μm pore size



cell migration

$50\ \mu\text{m}$ pore size after 5 hours



c-d: 110, 52, 25 and 12 μm



fs-microfabrication is a great tool for designing polymerbased devices

http://www.fotonica.ifsc.usp.br

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